

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Byoung-Kee KIM and Dong-Won LEE  
Serial No. : Not Yet Known  
Filed : Herewith  
For : METHOD OF MANUFACTURING NANOPHASE TiC-BASED  
COMPOSITE POWDERS BY METALLOTHERMIC REDUCTION

1185 Avenue of the Americas  
New York, New York 10036  
June 20, 2003

MAIL STOP PATENT APPLICATION  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

**PRELIMINARY AMENDMENT**

Prior to the initial examination of the above-identified application, applicants respectfully request that the application be amended as shown below.